

Appl. No. 10/075,193

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/075,193
Filing Date February 13, 2002
Inventor..... Shenlin Chen et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2813
Examiner Huynh, Y.
Attorney's Docket No. MI22-1927
Title: Methods of Forming a Capacitor Structure

RESPONSE TO NOVEMBER 4, 2002 OFFICE ACTION FAX RECEIVED

To: Box Non-Fee Amendment
Assistant Commissioner for Patents
Washington, D.C. 20231

NOV 20 2002

TECHNOLOGY CENTER 2800

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AMENDMENTS**In the Claims**

Please replace the entire set of claims with the following clean versions of the claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i).

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TECHNOLOGY CENTER 2800**CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:

1. Response to November 4, 2002 Office Action

Dated: 11-20-2002

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